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	Filing Date		2003-07-08
	First Named Inventor	Karim FAID et al.	
	Art Unit	1743	
	Examiner Name	Natalia A. LEVKOVICH	
	Attorney Docket Number	PAT 930-2	

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12	1	HSIA, et al., "Collapse of Stamps for Soft Lithography due to Interfacial Adhesion", Applied Physics Letters, April 6, 2005, Volume 86, Issue 15, id. 154106 (3 pages).	<input type="checkbox"/>
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